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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/809,419	03/26/2004	Kesahiro Koike	Q80754	6804
23373 SUGHRUE MI	7590 06/27/200 ON. PLLC	EXAMINER		
2100 PENNSYLVANIA AVENUE, N.W.			GOUDREAU, GEORGE A	
	SUITE 800 WASHINGTON, DC 20037		ART UNIT	PAPER NUMBER
			1792	
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Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

	Application No.	Applicant(s)	
	10/809,419	KOIKE, KESAHIRO	
Office Action Summary	Examiner	Art Unit	
	George A. Goudreau	1792	
The MAILING DATE of this communication a Period for Reply	ppears on the cover sheet with the	correspondence address	
A SHORTENED STATUTORY PERIOD FOR REF WHICHEVER IS LONGER, FROM THE MAILING - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period. - Failure to reply within the set or extended period for reply will, by stat Any reply received by the Office later than three months after the mail earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNICATIO 1.136(a). In no event, however, may a reply be ti od will apply and will expire SIX (6) MONTHS fron ute, cause the application to become ABANDONI	N. mely filed n the mailing date of this communication. ED (35 U.S.C. § 133).	
Status			
1) ☐ Responsive to communication(s) filed on 28 2a) ☐ This action is FINAL . 2b) ☐ The 3) ☐ Since this application is in condition for allow closed in accordance with the practice under the second of the s	nis action is non-final. vance except for formal matters, pr		
Disposition of Claims			
4) ☐ Claim(s) 1-24 is/are pending in the application 4a) Of the above claim(s) is/are withd 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 1-5 and 7-24 is/are rejected. 7) ☐ Claim(s) 6 is/are objected to. 8) ☐ Claim(s) are subject to restriction and Application Papers 9) ☐ The specification is objected to by the Exami	rawn from consideration. l/or election requirement.		
10) The drawing(s) filed on is/are: a) a Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the	ne drawing(s) be held in abeyance. Se ection is required if the drawing(s) is ob	ee 37 CFR 1.85(a). pjected to. See 37 CFR 1.121(d).	
Priority under 35 U.S.C. § 119			
 12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority docume 2. Certified copies of the priority docume 3. Copies of the certified copies of the priority docume application from the International Bure * See the attached detailed Office action for a light content. 	ents have been received. ents have been received in Applicationity documents have been receive eau (PCT Rule 17.2(a)).	tion No red in this National Stage	
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail E 5) Notice of Informal 6) Other:	oate	

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1. This action will not be made final due to the new grounds of rejection.

- 2. Applicant's arguments with respect to claims of record have been considered but are most in view of the new ground(s) of rejection.
- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).
- 5. Claims 1-5, and 7-24 are rejected under 35 U.S.C. 103(a) as being unpatentable over Cardinale (6,015,640) further in view of Hata et. al. (JP 63-114,866) and Takeuchi et. al. (2002/0,179,576).

Cardinale discloses a process for fabricating a EUV blank from glass, which is then used in the photolithographic patterning of a wafer. The EUV blank is fabricated using the following steps:

-A polished (i.e.-flattened) quartz substrate (i.e.-blank) is produced; and

-Alternating layers of Mo and Si are deposited onto the flat surface of the quartz blank. The Mo/Si layers on the quartz blank may be patterned using either a lift off process or etching process.

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This is discussed specifically in column 1; and discussed in general in columns 1-6. This is shown in figures 1-7. Cardinale fail, however, to specifically disclose the following aspects of applicant's claimed invention:

- -the specific usage of the process which is claimed by the applicant for polishing (i.e.-flattening) the top surface of the glass blank; and
- -the production of a EUV glass blank with the specific level of smoothness, which is claimed by the applicant

It would have been obvious to one skilled in the art to employ the specific means which claimed by the applicant for polishing (i.e.-flattening) the EUV glass blank in the process which is taught above based upon the following. This simply provides an alternative and at least equivalent means for polishing (i.e.-flattening) the EUV glass blank in the process, which is taught above to the specific means, which are taught above. Further, Hata et. al. and Takeuchi et. al. teaches methods for desirably polishing (i.e.-flattening) a glass blank. (i.e.-See below.)

(Hata et. al. discloses a process for preparing a glass mask blank which is comprised of the following steps:

- -The glass substrate is first mechanically ground to improve its flatness.;
- -The glass substrate is then wet etched in order to remove a damaged layer from the surface of the glass substrate. (The glass is wet etched with an acid if

silicate glass is used. The glass is alternatively wet etched with an alkali if phosphate group glass is used.); and

-The surface of the wet etched glass is then cmp polished to optically smooth the glass surface.

This is discussed specifically in the abstract; and discussed in general on pages 457-461. Hata et. al. fail to disclose, however, the following aspects of applicant's claimed invention:

-the specific usage of a plasma etching process to locally machine the surface of a glass substrate in order to increase the degree of flatness of the glass substrate based upon a profile measuring step; and

-the specific usage of the specific acids, and alkali wet etchants, which are claimed by the applicant to wet etch the surface of the glass blank in order to remove damage from the surface of the glass blank

Takeuchi et. al. teach that it is desirable to locally machine the surface of a glass substrate to remove peaks, and valleys in the surface of the glass substrate using a plasma etching process based upon a profile measuring step. This is discussed specifically in the abstract; and discussed in general on pages 1-3.

It would have been obvious to one skilled in the art to employ the flatness controlling means of Takeuchi et. al. to machine the surface of the glass blank in Hata et. al. based upon the following. This simply represents the usage of an alternative, and at least equivalent means for machining the surface of the glass blank to the specific means which are taught by Hata et. al. Further, Takeuchi et. al. teaches

that it is desirable to use their means for locally machining the surface of a glass substrate in order to improve the flatness of the glass substrate.

It would have been obvious to one skilled in the art to employ the specific acidic wet etchants, and alkaline wet etchants which are claimed by the applicant to wet etch the damaged surface layer of the glass substrate in the process which is taught above based upon the following. The specific acidic wet etchants, and alkaline wet etchants, which are claimed by the applicant, are conventionally used or at least well known for the wet etching of glass. (The examiner takes official notice in this regard.) Further, the specific usage of the specific wet etchants which are claimed by the applicant for wet etching the glass substrate which is taught by Hata et. al. simply represents the usage of an alternative, and at least equivalent means for wet etching the glass substrate to the specific means which are taught by Hata et. al.)

It would have been obvious to one skilled in the art to produce a EUV glass blank with the specific level of smoothness, which is claimed by the applicant based upon the following. It would have been desirable to provide a EUV glass blank with the desired optical properties by proving the top surface of the glass blank with an adequate level of smoothness to achieve those optical properties.

6. Claim 6 is objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

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7. Any inquiry concerning this communication should be directed to examiner

George A. Goudreau at telephone number 571-272-1434.

/George A. Goudreau/ Primary Examiner, Art Unit 1792